

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10076858	02/14/2002	428	426	1775	Stein

****APPLICANTS:** Steinberg Dan; Rasnake Jasean; Sherrer David;

**CONTINUING DATA VERIFIED:

THIS APPLN CLAIMS BENEFIT OF 60/269,011 02/14/2001
AND CLAIMS BENEFIT OF 60/269,010 02/14/2001

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

23091/25

TITLE : Micromachined structures made by combined wet and dry etching

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims <input type="checkbox"/> Print Claim for <input type="checkbox"/>	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner Application Examiner	
		PREPARED FOR ISSUE	
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